

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of : ATTN: BOX ISSUE FEE
DHINDSA, Rajinder et al. : Confirmation No. 8414
U.S. Patent Application No. 10/645,665 : Group Art Unit: 2821
Filed: August 22, 2003 : Allowed: April 1, 2008
For: MULTIPLE FREQUENCY PLASMA ETCH REACTOR : Examiner: TUNG X LE

**REQUEST TO CHANGE PTO RECORDS SO PATENT TITLE
REFLECTS THE AMENDMENT MADE JANUARY 13, 2006**

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

On January 13, 2006, applicants submitted a Preliminary Amendment changing the referenced application title to: MULTIPLE FREQUENCY PLASMA PROCESSOR METHOD AND APPARATUS. However, the Notice of Allowance mailed April 1, 2008, lists an erroneous title: MULTIPLE FREQUENCY PLASMA ETCH REACTOR PROCESSOR METHOD AND APPARATUS. Applicants request the PTO records be changed to reflect the correct application title.

Please charge any shortage in fees due in connection with the filing of this paper, including extension of time fees, to Deposit Account 07-1337 and please credit any excess fees to such deposit account.

Respectfully submitted,
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